

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2814
Serial No. : 09/362,808 Examiner : Shrinivas H. Rao
Filed : July 28, 1999 Conf. No. : 7320
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT AND
AND SUBMISSION OF CORRECTED FORM PTO-1449**

Supplemental to an information disclosure statement filed with the application on February 17, 2006, Applicants submit the attached corrected Form PTO-1449. All of the documents listed on the form PTO-1449 were cited in information disclosure statement filed February 17, 2006. The corrected Form PTO-1449 is being submitted to correct typographical errors in the description of reference “AP.” Applicants’ records show that this information disclosure statement complied with 37 CFR 1.97. Thus, it is respectfully requested that the examiner initial and return this form as soon as possible. Note, applicants must pay the issue fee by December 29, 2009, so the examiner’s prompt attention to this matter would be appreciated.

Respectfully submitted,

Date: 12/14/09

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